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Patent Application
2771-357 DIV (7486)IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: VAN BUSKIRK et al.

Application No.: 09/928,860

Date Filed: August 13, 2001

Title: SCALABLE LEAD ZIRCONIUM
TITANATE (PZT) THIN FILM
MATERIAL AND DEPOSITION
METHOD, AND FERROELECTRIC
MEMORY DEVICE STRUCTURES
COMPRISING SUCH THIN FILM
MATERIALDocket No.: 2771-357 DIV
Examiner: FULLER, Eric B.
Art Unit: 1762
Confirm. No.: 8391

Customer No.:

25559

FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Eric B. FULLER

Fax No.: (703) 872-9306

OFFICIAL

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Number of Pages (including cover)

Yongzhi Yang

August 12, 2004

Date

 RESPONSE TO MAY 28, 2004 OFFICE ACTION
 IN UNITED STATES PATENT APPLICATION NO. 09/928,860

Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir/Madam:

In response to the May 28, 2004 Final Office Action in the above-identified application, please amend the claims of the present application as set out in Section I (Amendments to Claims) hereof. Remarks concerning the Office Action are set out in Section II (Remarks) hereof.